AutoEdge: Precise and Accurate Xray Measurement with Compact Equipment

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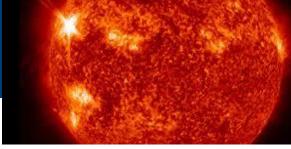
TFSM April 23-26, 2019

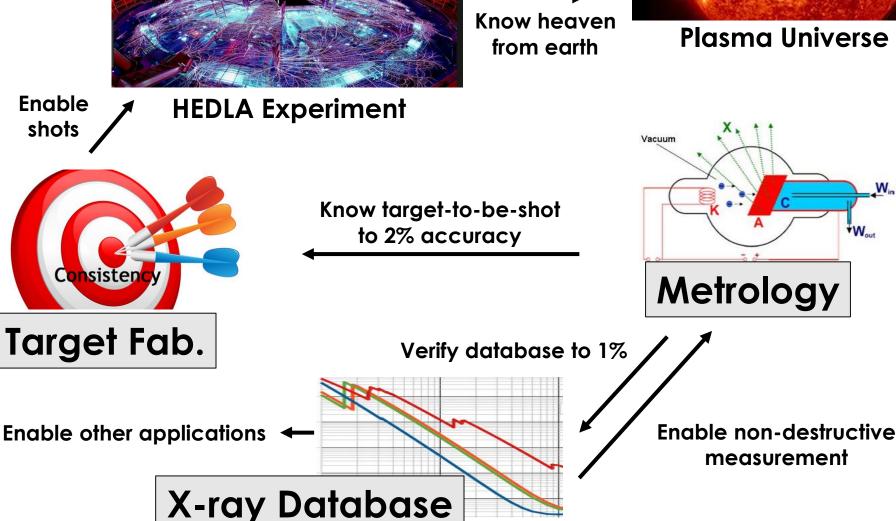
The metrology work is supported by General Atomics Internal R&D fund, The target fabrication work is supported by U.S. Department of Energy under Contract No. DE-NA0001808



IFT\P2019-025

High precision targets and metrology are central to HED experiments





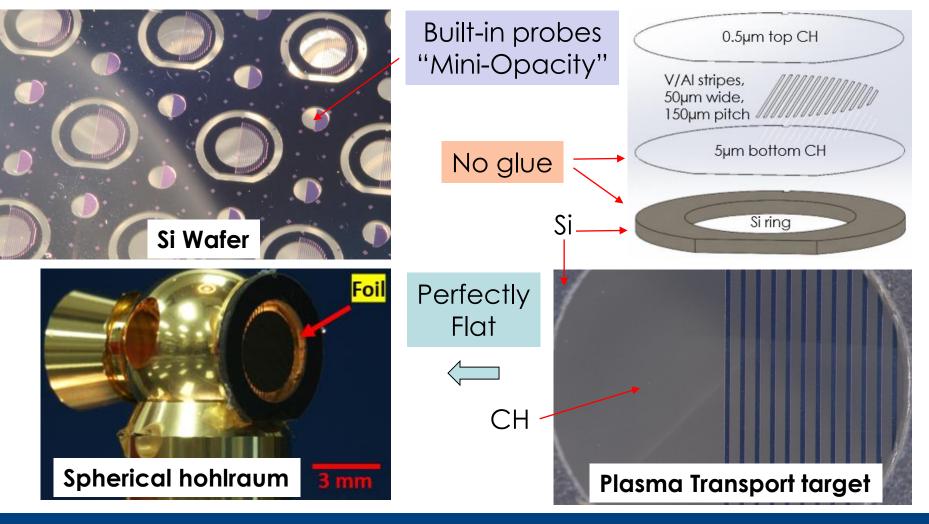


Bringing target fab and metrology into the semiconductor era

- New target fab approach
 - Photolithography
- New metrology equipment
 - AutoEdge
- How to prove precision to 1%?
 - Photon statistics
- How to prove accuracy to 1%?
 - X-ray database refinement



- Photolithography-based fabrication produces complex plasma-transport targets, impossible by contact mask
- Line pattern for inter-diffusion of high Z/Low Z



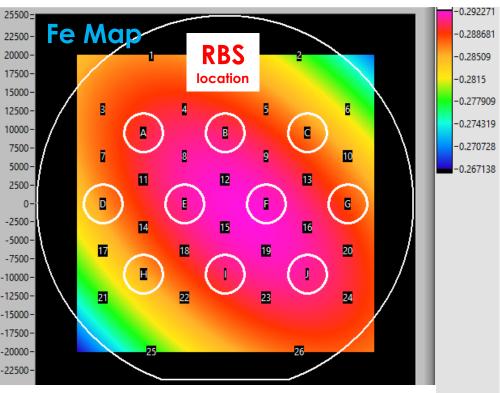


Free-standing ZAPP/Opacity targets enable quantification of actual targets rather than witness

- Xray measures both "cold opacity" and areal density
 - Baselining the anomalous "hot opacity" increase

"Solar opacity" problem



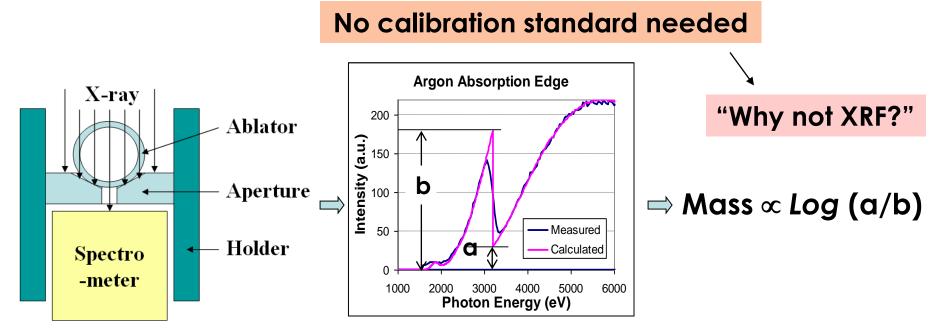


Fe Average 0.287um, $\pm 3\%$ Max-Min



New wine in old bottle: X-ray absorption spectroscopy is most relevant, can quantify metal foil areal density

• Old technique: Non-destructive, first principle



 New ingredient: New instrument to cross-check, discriminate and refine x-ray databases

"A strong-yet-unfulfilled need in HED"



New "AutoEdge" instrument pushes the precision and accuracy limits in x-ray absorption metrology



- New tool
 - Mo tube
 - Silicon Drift Detector
- Three goals
 - Metrology automation
 - Accuracy within 2%
 - Refine x-ray database

• Automation enables "Big data" approach

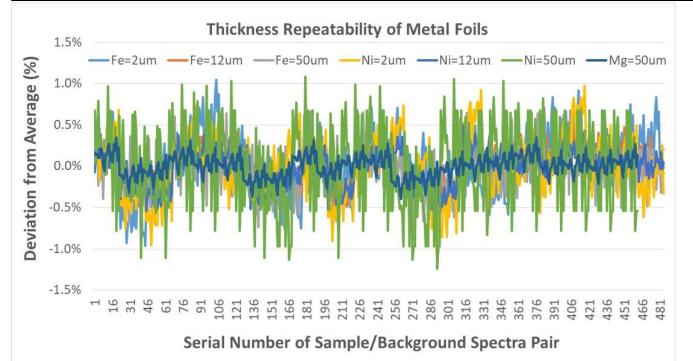
- Use spectrum ensemble to probe instrument behaviors
- Precision set by noise, mitigated by counting time
- Accuracy set by database, calibrated gravimetrically



30 minutes spectra on 2+ μ m metal foils measures thickness to within 0.5% (1- σ) precision

Thickness repeatability empirically determined

	Fe	Fe	Fe	Ni	Ni	Ni	Mg
Average (um)	2.331	12.375	52.090	2.072	12.185	50.658	45.517
StDev (um)	0.008	0.027	0.143	0.008	0.027	0.252	0.062
StDev (%)	0.36%	0.22%	0.27%	0.37%	0.22%	0.50%	0.14%

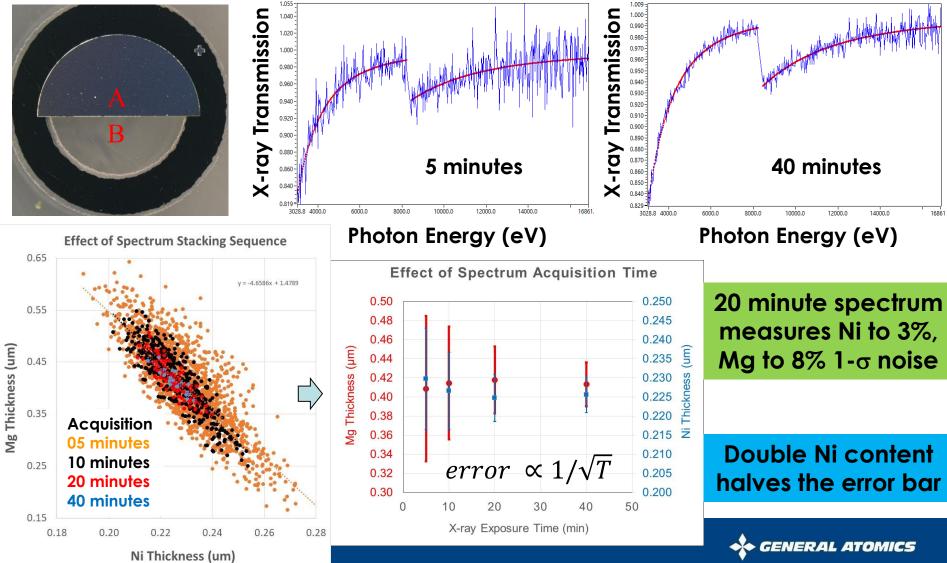


Applicable to NIF diagnostic filter foils



Precision set by photon-counting noise, empirically studied through spectral ensemble





Compiled five "standard" x-ray databases into one program to enable benchmarking and calibration

• Rude awakening: 90 sec that shatters "trusted" data

Name	Z	Energy	Purpose & Source
NIST XCOM	1-100	1k-100G	Absorption https://physics.nist.gov/PhysRefData/Xcom/html/xcom1.html
NIST XFFAST	1-92	1-433k	Diffraction https://physics.nist.gov/PhysRefData/FFast/html/form.html
LBNL Henkie	1-92	30-30k	Optics http://henke.lbl.gov/optical_constants/pert_form.html
SNL	1-100	10-1M+	HED 1988 Report, "Analytical Approximations for X-Ray Cross Sections"
LLNL	194	1k-1M	HED 1969 Report, "Compilation of X-Ray Cross Sections"

Old data not so great

- Source data from 1930-1970s, before microelectronics

New data not forthcoming

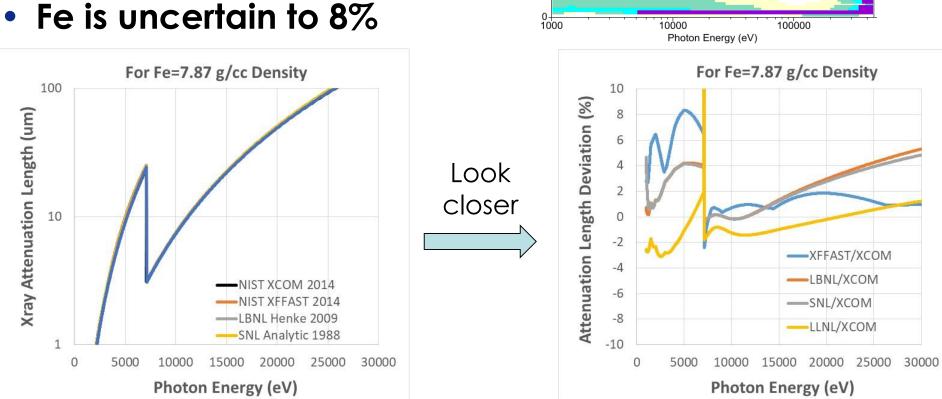
 Shutdown of Brookhaven beamline left the US HED program in the dark: No more synchrotron access



NIST treats **XCOM-XFFAST** as limit of knowledge on opacity

Green is 5-10% uncertainty

https://physics.nist.gov/PhysRefData/XrayNoteB.html



80

Atomic Number 09

20

1000

Fractional Difference in Photoelectric Cross Section

(FFAST - XCOM) / XCOM · 100

10000

100000

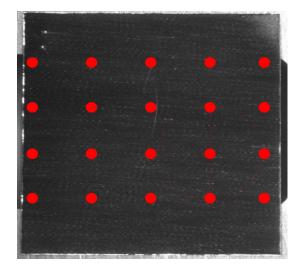
ver 50 %

11

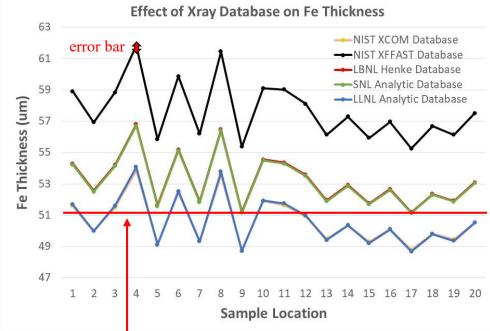
For Opacity and Diffusion Experiments: Ni, Mg, V, Al are not any better

Automated areal scan enables benchmarking against gravimetric thickness on imperfect foils

Fe Thickness Calibration	Micron	Deviation (%)
Gravimetric (0.1um 1-σ)	51.11	0%
NIST XCOM	50.62	-1%
NIST XFFAST	57.66	13%
LBNL Henkie	53.23	4%
SNL Analytic	53.16	4%
LLNL Analytic	50.64	-1%
Average	53.06	4%



Scan a 1" x 1" Fe foil



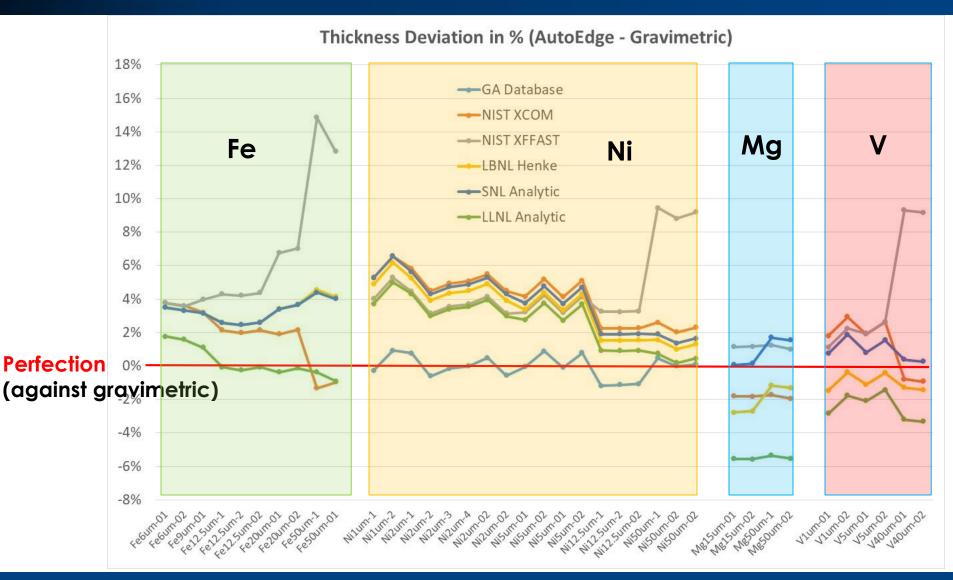
Gravimetric average: 51.11 µm

Gravimetric uncertainty: $\pm 0.1 \ \mu m$ X-ray sampling uncertainty: $\pm 0.4 \ \mu m$

Check x-ray database to 1% accuracy



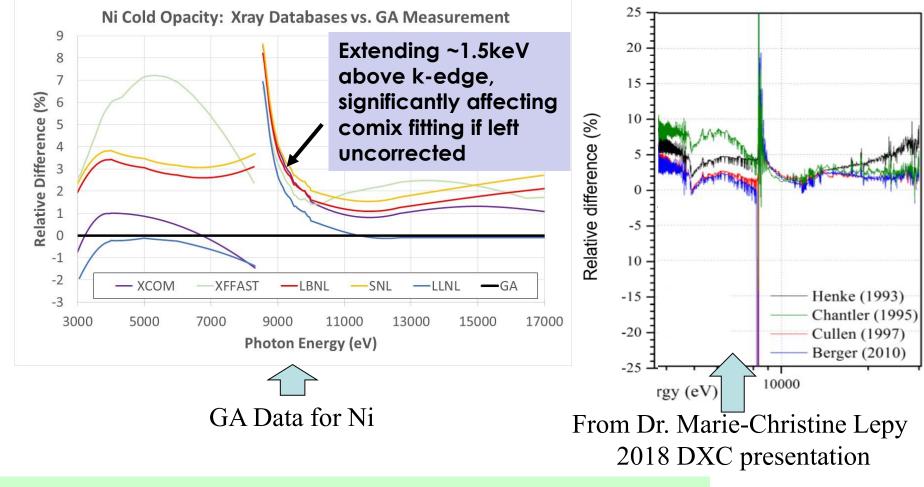
"GA database" corrects areal density measurement to ~1% accuracy, about 5x reduction in error





Ni opacity data from GA agrees to CEA-PTB synchrotron data to ~1% in common energy range of 3-17keV

Both suggest earlier databases have >5% error, especially above K edge



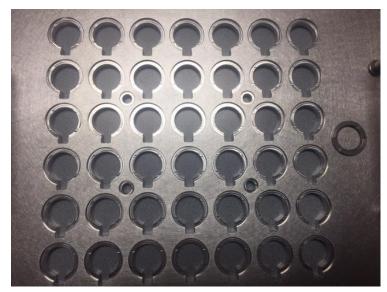
Joined "International Initiative on X-ray Fundamental Parameters" to participate in standard-setting activities

GENERAL ATOMICS

Precision metrology enables precision target fab, Portable instrument shows promise in opacity revision

- Photolithography => complex and rep-rate targets
- AutoEdge => 1% precision, measuring actual targets

 Systematic calibration of Comix, Dante filter, Ross Pair
- GA database => 1% accuracy via "element" projects



Ready to go: Calibrate 500 Dante filters in 12 batches (annual NIF consumption)

